Special Issue

Additive Manufacturing: Materials, Processing, Characterization and Applications

Message from the Guest Editors

This Special Issue intends to address the latest progress in the AM field. Original contributions related to current AM materials and processing for applications are welcome in the form of short communications, fulllength articles, and reviews. Potential topics include but are not limited to:

- AM material characterization;
- New materials for AM;
- AM process development;
- Material and microstrucural properties evaluation during the AM process;
- Post-processing of AM materials;
- Hybrid AM processes and materials;
- Modeling and simulation of AM processing;
- AM applications;
- Standardization of AM material performance.

Guest Editors

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Prof. Dr. Takayoshi Nakano

Dr. Jiaming Bai

Deadline for manuscript submissions

closed (31 December 2021)



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About the Journal

Message from the Editor-in-Chief

Welcome to *Crystals*, the journal dedicated to the fascinating world of crystallographic research! Crystals are more than mere decorative elements; they hold the key to understanding the fundamental structure of matter. Our mission is to explore the crucial significance of this research across various fields. From medicine to technology, chemistry to geology, crystals play a vital role. Their structure provides insights into new advanced materials, innovative drugs, and groundbreaking technologies. Through *Crystals*, we delve into the microscopic world to discover solutions that will shape the future. Join us on a journey through the *Crystals*, where science merges with beauty and innovation.

Editor-in-Chief

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